

<b>Notice of References Cited</b>	Application/Control No. 10/624,733	Applicant(s)/Patent Under Reexamination KOBASHIKAWA ET AL.	
	Examiner Shew-Fen Lin	Art Unit 2166	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,952,805 B1	10-2005	Tafoya et al.	715/739
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

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